

**Search Notes**

Application/Control No.

10/774,194

Examiner

Quovaunda Jefferson

Applicant(s)/Patent under  
Reexamination

HUANG, YI-CHIAU

Art Unit

2823

**SEARCHED**

Class	Subclass	Date	Examiner

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST USPAT, US-PGPUB, USOCR, JPO,EPO,DEWENT,IBM_TBP	8/12/2005	QVJ
NPL:Handbook of Semiconductor Wafer Cleaning Technology - Science, Technology, and Applications Edited by: Kern, W. © 1993;	8/12/2005	QVJ